



PATENT

Atty. Dkt. No. AMAT/5908.Y1/CPI/ALUMINUM/PJS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Wang, et al.

Serial No.: 10/046,954

Confirmation No.: 4418

Filed: January 14, 2002

For: Semiconductor Wafer
Preheating

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§ Group Art Unit: 2125
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§ Examiner: Kidest Bahta
§
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MAIL STOP RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

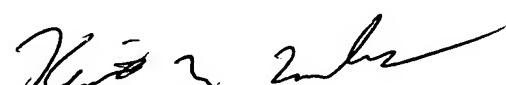
Dear Sir:

CERTIFICATE UNDER 37 CFR 1.10	
I hereby certify that this correspondence and the documents referred to as attached therein are being deposited on <u>4/14/05</u> , 2005 with the United States Postal Service in an envelope as "Express Mail Post Office to Addressee," mailing label No. <u>EV321685281US</u> addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.	
<u>4/14/05</u>	<u>Kidest Bahta</u>
Date	Signature

REQUEST FOR NON-ENTRY OF AMENDMENT

Applicants respectfully request non-entry of the Response filed by facsimile on February 10, 2005, to the Final Office Action dated December 14, 2004. Applicants also respectfully request non-entry of the Response filed by facsimile on March 11, 2005, to the Final Office Action dated December 14, 2004.

Respectfully submitted,


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